

**Materials List for:**

**Characterization of Surface Modifications by White Light Interferometry: Applications in Ion Sputtering, Laser Ablation, and Tribology Experiments**

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URL: <https://www.jove.com/video/50260>

DOI: [doi:10.3791/50260](https://doi.org/10.3791/50260)

**Materials**

Name	Company	Catalog Number	Comments
Single crystal substrates of Si, GaAs and Cu			for sputtering and ablation
Pure metal alloys			for tribology examples